



PATENT
Attorney Docket No: AUB-06300

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Yonhua Tzeng

Serial No.: 10/772,740

Filed: February 5, 2004

For: **METHOD OF PLASMA
ENHANCED CHEMICAL VAPOR
DEPOSITION OF DIAMOND
USING METHANOL-BASED
SOLUTIONS**

) Group Art Unit: 1762
) Examiner: Stouffer, Kelly M.
)
)
) **AMENDMENT AND REQUEST FOR
CONTINUED EXAMINATION (RCE)**
)
) 162 North Wolfe Road
) Sunnyvale, California 94086
) (408) 530-9700
)
) Customer No.: 28960

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

AMENDMENTS

Sir:

Please amend the subject application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Remarks/Arguments begin on page 7 of this paper.